# **Electronic Acknowledgement Receipt** FES ID: 1088705 Application Number: 10552513 Confirmation Number: 2406 Crystalline-si-layer-bearing substrate and its production method, and Title of Invention: crystalline si device First Named Inventor: Yasushi Araki Customer Number: 23373 Filer: Kelly G. Hyndman/LAYONDA PRUE Filer Authorized By: Kelly G. Hyndman Attorney Docket Number: O90689 Receipt Date: 22-JUN-2006 Filing Date: 06-OCT-2005 Time Stamp: 15:52:46 Application Type: U.S. National Stage under 35 USC 371 International Application Number: Payment information:

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## File Listing:

Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Request for Corrected Filing Receipt	Q90689reqforcorrectedofr2n dscan.pdf	241867	no	6

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## New Applications Under 35 U.S.C. 111

If a new application is being filed and the application includes the necessary components for a filing date (see 37 CFR 1.53(b)-(d) and MPEP 506), a Filing Receipt (37 CFR 1.54) will be issued in due course and the date shown on this Acknowledgement Receipt will establish the filing date of the application.

### National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/IDO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filling Receipt, in due course.